



INDIAN INSTITUTE OF TECHNOLOGY BOMBAY

MATERIALS MANAGEMENT DIVISION

11th Aug, 2021

Corrigendum –III

For (PR No. 1000020717) RFx No. 6100000743

Plasma Etcher with Deposition Capability Plasma Etcher with Deposition Capability

Sr. No.	Online RFx Clause	Previous Clause	Changed Clause
1.	Bid submission End Date/Date & Time of submission (Online RFx clause)	11.08.2021 at 13.00	18.08.2021 at 13.00
2.	Bid Opening Date & Time (Online RFx clause)	11.08.2021 at 15.00	18.08.2021 at 15.00

Additional Registrar

Materials Management Division